Form PTO-1449 U.S. Dept. of Commerce Patent & Trademark Office					Atty. Docket: 00-GR1-408 Serial No.: 10/044,286				
List of Documents Cited by Applicant (Use several sheets if necessary)				Applicant: Olivier MENUT et al.					
				Filing Date: January 11, 2002 Group: 2814					
					.S. PATENT DOCUMENTS				
Extrs in/		Document - Number	Date		Name	Class .	Sub- class	Filing Date, if applicable	
1/1	AAI	5,307,169	April 26, 199	4	Nagasaki et al.			·	
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		Document Number	Date		Country	Class	Sub-	Transi'n Yes/No	
1/	AA2	WO99/48152	September 2	3, 1999	PCT			Yes	
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-7		ОТН	ER DOCL	MENT	S (Including Author, Title, Date, Pertin	ent Pages, Etc	.)		
AA3 "One-Device CMOS Dram Cell with Buried Poly Trench and Drain Reach Through," IBM Technical Disclosure Bulletin, pp 451-452, Vol. 30, No. 11, April 1988.									
	"Vertical Conducting Connection to a Poly-Si Trench In Si," IBM Technical Disclosure Bulletin, pp. 310-312, Vol. 31, No. 12, May 1989.								
AA5 Preliminary Search Report dated October 19, 2001 for French Patent Application No. 0100420.									
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